



PATENT  
37904-0058

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Yasuo Ohama  
U.S. Serial No. : 10/555,853  
Filing date : November 1, 2005  
Title : QUARTZ GLASS CRUCIBLE FOR PULLING UP SILICON  
SINGLE CRYSTAL AND METHOD FOR MANUFACTURE  
THEREOF  
Art Unit : 1792  
Examiner : Matthew J. Song

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Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

STATEMENT PURSUANT to 35 U.S.C. § 103(c)(2)

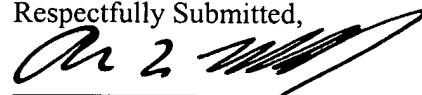
Sir:

Applicant hereby states that the claimed invention was made by or on behalf of Heraeus Quarzglas GmbH & Co. KG, which was party to a joint research agreement with Shin-Etsu Quartz Products, Ltd. And to a linked subsequent agreement between Heraeus Quarzglas GmbH, Shin-Etsu Quartz Products and Heraeus Shin-Etsu America, Inc.

The joint research agreement was in effect on or before the claimed invention was made, and the claimed invention was made as a result of activities undertaken within the scope of the joint research agreement.

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Respectfully Submitted,

  
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